REQUEST FOR

Application Number	10/565,004	
Confirmation Number	5166	
Filing Date	January 19, 2006	
First Named Inventor	Tsuyoshi UEHARA	
Group Art Unit	1792	
Examiner Name	Keath T CHEN	
Matter Number	O92479	
PLASMA PROCESSING APPARATUS AND		

CONTINUED EXAMINATION (RCL)	Filing Date	January 19, 2006	
TRANSMITTAL	First Named Inventor	Tsuyoshi UEHARA	
MAIL STOP RCE	Group Art Unit	1792	
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	Examiner Name	Keath T CHEN	
Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000,	Matter Number	O92479	
provides for continued examination of an utility or plant application filed on or after June 8, 1995	Title PLASMA PROCESSING APPARATUS AND ELECTRODE STRUCTURE		
This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.			
a. UBMISSION REQUIRED UNDER 37 C.F.R. § 1.114 a. Previously submitted i. Please enter and consider the amendment(s)/repl previously filed on ii. Consider the arguments in the Appeal Brief or R iii. Other	_		
b. ☐ Enclosed i. ☐ Amendment/Reply ii. ☐ Affidavit(s)/Declaration(s) iii. ☐ Information Disclosure Statements (IDS) iv. ☐ Petition for Extension of Time v. ☐ Other			
b. Other			
3. FEES The RCE statutory fee of \$\$10.00 is being charged to The USPTO is directed and authorized to charge all required to Deposit Account No. 19-4880. Please also credit any overpay	ees, except for the Issue I	ee and the Publication Fee, to	
CORRESPONDENCE ADDRESS Direct all correspondence to the address for SUGHRUE MION, PLLC filed under the Customer Number listed below:			
Direct all correspondence to the address for SUGHRUE MIC WASHINGTON OFFICE	IN, PLLC Juea under the	Customer Ivamoer tisted below.	
23373 CUSTOMER NUMBER			
SIGNATURE OF ATTORNEY			
Name David P. Emery F	Registration No. 55,154		
Signature	Date February 14, 2008		